

**AMENDMENTS TO THE CLAIMS**

1. (Previously presented) An image pixel structure, comprising:

a semiconductor substrate of a first conductivity type having a surface;

a gate over a surface of the substrate; and

a photodiode within said substrate, said photodiode including an implant region of a second conductivity type, a first portion of said implant region having a lower boundary in said substrate and extending further towards a region of said substrate beneath said gate than a second portion of said implant region extends towards said region beneath said gate,

wherein said second portion is adjacent to and substantially underneath said first portion such that said lower boundary of said first portion forms an upper boundary for at least a part of said second portion.

2. (Original) The image pixel structure of claim 1, wherein the substrate is p-type, and the implants are n-type.

3. (Original) The image pixel structure of claim 1, wherein the substrate is n-type, and the implants are p-type.

4. (Currently amended) The image pixel structure of claim 1, wherein an upper portion of said implant region is farther away from the region beneath said gate than ~~the other~~ portions of the implant region located beneath said upper portion.

5. (Previously presented) The image pixel structure of claim 1, wherein said first portion is nearest the substrate surface in the implant region.

6. (Original) The image pixel structure of claim 5, wherein the implant dose of the first portion is between  $2E11$ - $1E13/cm^2$ .

7. (Canceled)

8. (Previously presented) The image pixel structure of claim 1, wherein the implant dose of the second portion is between  $2E11$ - $1E13/cm^2$ .

9. (Previously presented) The image pixel structure of claim 1, wherein the implant region includes a third portion, said third portion being underneath the second portion in the implant region.

10. (Original) The image pixel structure of claim 9, where the implant dose of the third portion is between  $2E11$ - $1E13/cm^2$ .

11. (Original) The image pixel structure of claim 9, wherein the first, second, and third portions of the implant region are formed by implants angled between 0 and 30 degrees in the direction of the gate, said angle being measured away from a line normal to the surface of the substrate, with at least one of the implants being at an angle greater than 0 degrees.

12. (Original) The image pixel structure of claim 11, wherein the third portion extends further than the first and second portions towards the region of said substrate beneath said gate.

13. (Original) The image pixel structure of claim 9, wherein the implant angle for the first and second portions of the implant region is between 0-15 degrees, and the implant angle for the third portion is between 0-30 degrees, at least one of said implant angles being greater than 0 degrees.

14. (Original) The image pixel structure of claim 12, wherein the implant angle for the first and second portions of the implant region is between 0-10 degrees, and the implant angle for the third portion is between 0-15 degrees.

15. (Original) The image pixel structure of claim 11, wherein the second portion extends further than the first and third portions towards the region of said substrate beneath said gate.

16. (Original) The image pixel structure of claim 9, wherein the implant region includes a fourth portion, said fourth portion being lateral to the second portion in the direction of the gate.

17. (Original) The image pixel structure of claim 16, where the implant dose of the fourth portion is between  $2\text{E}11\text{-}1\text{E}13/\text{cm}^2$ .

18. (Original) The image pixel structure of claim 16, wherein the fourth portion extends further than the first, second, and third portions towards the region of said substrate beneath said gate.

19. (Original) The image pixel structure of claim 18, wherein the first, second, and third portions of the implant region are formed by implants angled between 0 and 5 degrees in the direction of the gate, said angle being measured away from a line normal to the surface of the substrate.

20. (Original) The image pixel structure of claim 19, wherein the fourth portion is formed by an implant angled between 10 and 30 degrees in the direction of the gate, said angle being measured away from a line normal to the surface of the substrate.

21. (Original) The image pixel structure of claim 1, wherein at least one of said portions of said implant region is angled.

22. (Original) The image pixel structure of claim 1, wherein the image pixel structure is a CCD imager.

23. (Original) The image pixel structure of claim 1, wherein the image pixel structure is a CMOS imager.

24. (Original) The image pixel structure of claim 23, wherein said image pixel structure is one of a three transistor (3T), four transistor (4T) five transistor (5T), six transistor (6T) and seven transistor (7T) structure.

25. (Original) The image pixel structure of claim 1, wherein said gate includes a gate oxide and a conductor.

26. (Original) The image pixel structure of claim 25, wherein said conductor contains at least one of poly-silicon, silicide, metal, and any combination of poly-silicon, silicide and metal.

27. (Original) The image pixel structure of claim 25, wherein said gate includes an insulator over the conductor.

28. (Original) The image pixel structure of claim 27, wherein the insulator is formed from at least one of oxide, nitride, metal oxide, and any combination of oxide, nitride, and metal oxide.

29-53. (Canceled)

54. (Previously presented) A pixel imager system, comprising:

- (i) a processor; and
- (ii) a CMOS imaging device coupled to said processor and including:

a pixel array, at least one pixel of said array comprising:

a semiconductor substrate of a first conductivity type having  
a surface;

a gate over a surface of the substrate; and

a photodiode, within said substrate, said photodiode  
including an implant region of a second conductivity type, a first  
portion of said implant region which extends further towards a  
region of said substrate beneath said gate than a second portion of  
said implant region,

wherein said second portion is substantially underneath  
said first portion such that at least a portion of a lower boundary of  
said first portion forms an upper boundary for said second portion.

55. (Original) The pixel imager system of claim 54, wherein the substrate is p-type, and the implants are n-type.

56. (Original) The pixel imager system of claim 54, wherein the substrate is n-type, and the implants are p-type.

57. (Currently amended) The pixel imager system of claim 54, wherein an upper portion of said implant region is farther away from the region beneath said gate than ~~the other~~ portions of the implant region located beneath said upper portion.

58. (Previously presented) The pixel imager system of claim 54, wherein said first portion is nearest the substrate surface in the implant region.

59. (Original) The pixel imager system of claim 58, wherein the implant dose of the first portion is between  $2E11$ - $1E13/cm^2$ .

60. (Canceled)

61. (Previously presented) The pixel imager system of claim 54, wherein the implant dose of the second portion is between  $2E11$ - $1E13/cm^2$ .

62. (Previously presented) The pixel imager system of claim 54, wherein the implant region includes a third portion, said third portion being underneath the second portion in the implant region.

63. (Original) The pixel imager system of claim 62, where the implant dose of the third portion is between  $2E11$ - $1E13/cm^2$ .

64. (Original) The pixel imager system of claim 62, wherein the first, second, and third portions of the implant region are formed by implants angled between 0 and 30 degrees in the direction of the gate, said angle being measured away from a line normal to the surface of the substrate, with at least one of the implants being at an angle greater than 0 degrees.

65. (Original) The pixel imager system of claim 64, wherein the third portion extends further than the first and second portions towards the region of said substrate beneath said gate.

66. (Original) The pixel imager system of claim 62, wherein the implant angle for the first and second portions of the implant region is between 0-15 degrees, and the implant angle for the third portion is between 0-30 degrees, at least one of said implant angles being greater than 0 degrees.



67. (Original) The pixel imager system of claim 65, wherein the implant angle for the first and second portions of the implant region is between 0-10 degrees, and the implant angle for the third portion is between 0-15 degrees.

68. (Original) The pixel imager system of claim 64, wherein the second portion extends further than the first and third portions towards the region of said substrate beneath said gate.

69. (Original) The pixel imager system of claim 62, wherein the implant region includes a fourth portion, said fourth portion being lateral to the second portion in the direction of the gate.

70. (Original) The pixel imager system of claim 69, where the implant dose of the fourth portion is between  $2 \times 10^{11}$ - $1 \times 10^{13}$ /cm<sup>2</sup>.

71. (Original) The pixel imager system of claim 69, wherein the fourth portion extends further than the first, second, and third portions towards the region of said substrate beneath said gate.

72. (Original) The pixel imager system of claim 71, wherein the first, second, and third portions of the implant region are formed by implants angled between 0 and

5 degrees in the direction of the gate, said angle being measured away from a line normal to the surface of the substrate.

73. (Original) The pixel imager system of claim 72, wherein the fourth portion is formed by an implant angled between 10 and 30 degrees in the direction of the gate, said angle being measured away from a line normal to the surface of the substrate.

74. (Original) The pixel imager system of claim 54, wherein at least one of said portion of implant regions are angled.

75. (Original) The pixel imager system of claim 54, wherein the pixel imager system is a CCD imager.

76. (Original) The pixel imager system of claim 54, wherein the pixel imager system is a CMOS imager.

77. (Original) The pixel imager system of claim 76, wherein said imager device is one of a three transistor (3T), four transistor (4T) five transistor (5T), six transistor (6T) or seven transistor (7T) architecture.

78. (Previously presented) An imager pixel structure comprising:

a semiconductor substrate of a first conductivity type having an upper surface;

a transistor gate structure formed over the upper surface of the substrate;

a photosensor within said substrate, said photosensor including in implant region of a second conductivity type, said implant region including first, second, and third implant portions constructed such that said first implant portion extends further towards a region of said substrate beneath said gate than at least one of said second and third implant portions,

wherein said second portion is adjacent to and at least partially underneath said first portion and said third portion is adjacent to and substantially underneath said first portion.

79. (Previously presented) The image pixel structure of claim 78, wherein said first implant portion extends further than both said second and third regions extend toward said region in the substrate beneath said gate structure.

80. (Previously presented) The image pixel structure of claim 78, wherein the first, second, and third portions of the implant region are formed by implants angled between 0 and 30 degrees in the direction of the gate, said angle being measured away from a line normal to the surface of the substrate, with at least one of the implants being at an angle greater than 0 degrees.

81. (Previously presented) The image pixel structure of claim 78, wherein the third portion extends further than the first and second portions towards the region of said substrate beneath said gate.

82. (Previously presented) The image pixel structure of claim 80, wherein the implant angle for the first and second portions of the implant region is between 0-15 degrees, and the implant angle for the third portion is between 0-30 degrees, at least one of said implant angles being greater than 0 degrees.

83. (New) An image pixel structure comprising:

a photosensor formed in a semiconductor substrate of a first conductivity type, the photosensor comprising:

a first angled implant region of a second conductivity type, the first implant region being formed by implanting second conductivity type ions into said substrate at a first angle with a first energy level;

a second angled implant region of a second conductivity type, the second implant region being formed by implanting said second conductivity type ions into said substrate at a second angle with a second energy level; and

a third angled implant region of a second conductivity type, the third implant region being formed by implanting said second conductivity type ions into said substrate at a third angle with a third energy level,

wherein said first, second and third angles are within the range of about 0 to about 30 degrees from normal and at least one of said angles is greater than 0 degrees, and wherein at least one of said first, second, or third energy levels is not equal to the other energy levels; and

a transistor gate stack located at a surface of the semiconductor substrate adjacent said photosensor.

84. (New) The image pixel structure of claim 83, wherein said first, second, and third angles are within the range of about 0 to about 5 degrees from normal.

85. (New) The image pixel structure of claim 83, wherein said first energy level is lower than said second and third energy levels.

86. (New) The image pixel structure of claim 85, wherein said first energy level is in the range of about 5 to about 100 KeV.

87. (New) The image pixel structure of claim 86, wherein the second energy level is within the range of about 50 to about 250 KeV.

88. (New) The image pixel structure of claim 87, wherein the third energy level is within the range of about 100 to about 400 KeV.

89. (New) The image pixel structure of claim 83, wherein said photosensor further comprises a fourth angled implant region located adjacent said second angled implant region.

90. (New) The image pixel structure of claim 89, wherein said fourth angled implant region is located on a side of either said second or third angled implant region, at a portion in said substrate nearest said gatestack.

91. (New) The image pixel structure of claim 83, wherein a lower boundary for said first angled implant region creates an upper boundary for said second angled implant region, and wherein a lower boundary for said second angled implant region creates an upper boundary for said third angled implant region.

92. (New) The image pixel structure of claim 91, wherein at least one of said first, second, or third angled implant region extends further in a horizontal direction in said substrate than at least one other of said angled implant regions.

93. (New) The image pixel structure of claim 92, wherein said first angled implant region extends further in a horizontal direction in said substrate than said second or third angled implant region extends.

94. (New) The image pixel structure of claim 92, wherein said second and third angled implant regions extend further in a horizontal direction than said first angled implant region extends.